	Type	#	Hits	Search Text	DBs	Time Stamp	Comment s	Error Definition	H CH
F-4	BRS		10601	TFT or (thin near2 film near2 transistor\$1)	USPA T	2001/09/2 0 16:59			
	BRS	L2	2963	((gate near3 insulat\$4) or (gate near3 dielectric))same (silicon near2 nitride or SiN) and . (silicon near2 oxide or SiO)	USPA T	2001/09/2 0 17:00			0
3	BRS	L3	356	Hydrogen and 1 and 2	USPA T	2001/09/2 0 16:59		***************************************	0
4	BRS	L4	478	TFT or (thin near2 film near2 transistor\$1)	US-P GPUB	2001/09/2 0 17:00			0
5	BRS	, I 2	155	((gate near3 insulat\$4) or (gate near3 dielectric))same (silicon near2 nitride or SiN) and (silicon near2 oxide or SiO)	US-P GPUB	2001/09/2 0 16:59			0
9	BRS	97	36	ogen and 4 and 5	US-P GPUB	2001/09/2 0 17:00			0
7	BRS	L7	1984	TFT or (thin near2 film near2 transistor\$1)	EPO	2001/09/2 0 17:01			0
	BRS	Б Г	57	((gate near3 insulat\$4) or (gate near3 dielectric)) same (silicon near2 nitride or SiN) and (silicon near2 oxide or SiO)	EPO	2001/09/2 0 17:01			0

	Туре	# 1	K. Hits	Search Text	DBs	Time (Stamp	Comment	Error Definition	HO HO
6	BRS	L9	0	Hydrogen and 7 and 8	EPO	2001/09/2 0 17:02			0
10	BRS	L10	11495	TFT or (thin near2) film near2 transistor\$1)	JPO	2001/09/2 0 17:02			0
11	BRS	L11	526	((gate near3 insulat\$4) or (gate near3 dielectric))same (silicon near2 nitride or SiN) and (silicon near2 oxide or SiO)	JPO	2001/09/2 0 17:02			0
12	BRS	L12	12	Hydrogen and 10 and 11	JPO	2001/09/2 0 17:03			0
13	BRS	L13	13363	TFT or (thin near2 863film near2 transistor\$1)	DERW	2001/09/2 0 17:02			0
14	BRS	L14	2 6 2	((gate near3 insulat\$4) or (gate near3 dielectric))same (silicon near2 nitride or SiN) and (silicon near2 oxide or SiO)	DERW	2001/09/2 0 17:03			. 0
15	BRS	L15	3	Hydrogen and 13 and 14	DERW ENT	2001/09/2 0 17:03			0